



PATENT
Attorney Docket No. 1110/90738

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application)

Confirmation No.: 1669

Applicant: Komiya et al.)

*I hereby certify that this
correspondence is being deposited
with the United Postal Service as first
class mail in an envelope addressed
to: Mail Stop AMENDMENT,
Commissioner of Patents, P.O. Box
1450, Alexandria, VA, 22313-1450.*

Serial No.: 10/679,031)

Filed: October 3, 2003)

For: **SILICON WAFER AND
METHOD FOR MANUFACTURE THEREOF,
AND METHOD OF EVALUATION OF SILICON
WAFER**)

January 11, 2007

Examiner: M.J. Song)

Gerald T. Shekleton Reg. No. 27,466

Art Unit: 1722

AMENDMENT

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

The Office Action of July 14, 2006, has been carefully reviewed and the following
amendments and remarks are made in response thereto.